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Electronic Version v1.1

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Title	of
Invent	ion

Process for Applying a Thin-film Radiation-cured Coating on a Three-dimensional Substrate

Application Number:

Date:

First Named Applicant:

David Hagopian

Confirmation Number:

Attorney Docket Number:

27475/06963

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Submitted By:	Elec. Sign.	Sign. Capacity
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Documents being submitted:	Files
us-request	2747506963-usrequ.xml
	us-request.dtd
	us-request.xsl
us-fee-sheet	2747506963-usfees.xml
	us-fee-sheet.xsl
	us-fee-sheet.dtd
us-declaration	D4.tif
application-body	6963app-trans.xml
	us-application-body.xsl
	application-body.dtd
	wipo.ent
	mathml2.dtd
	mathml2-qname-1.mod
	isoamsa.ent
	isoamsb.ent
	isoamsc.ent
	isoamsn.ent
	isoamso.ent
	isoamsr.ent
	isogrk3.ent
	isomfrk.ent
	isomopf.ent
	isomscr.ent
	isotech.ent
	isobox.ent
	isocyr1.ent
	isocyr2.ent
	isodia.ent
	isolat1.ent
	isolat7.ent
	isonum.ent
	isopub.ent
	mmlextra.ent
	mmlalias.ent
	soextblx.dtd
	Fig1.tif
	Fig2.tif
	Fig3.tif
	Fig4.tif
	Fig5.tif
	Fig6.tif
	Fig7.tif
	Fig8.tif
	Fig9.tif
	Fig10.tif
	Fig11.tif
	Fig12.tif
	Fig13.tif
us-declaration	D1.tif
	₩ 1.UI

us-declaration	D2.tif	
us-declaration	D3.tif	
Comments		